IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

plicant:

Choi et al.

Appl. No.:

10/616,294

July 9, 2003

GPAU.: Examiner: 1722

Filed:

G. Nagesh Rao

Docket No.:

P92-34-03

Conf. No.:

1597

For:

Systems for Magnification and Distortion Correction For Imprint

Lithography Processes

## **PETITION UNDER 37 CFR § 1.313(c)(2)**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants hereby petition to withdraw the above-mentioned patent application [the "APPLICATION"] from issue. According to 37 CFR § 1.313(c)(2), an application may be withdrawn from issue after payment of issue fee if a Request for Continued Examination in compliance with 37 CFR § 1.114 is made. Specifically, Applicants wish to submit an Information Disclosure Statement [the "IDS"] in compliance with Applicants' duty of disclosure under 37 CFR § 1.56 in the APPLICATION. However, the IDS is being filed after payment of issue fee, wherein the payment of issue fee occurred on or about May 11, 2006. To that end, Applicants wish to withdraw the APPLICATION from issue so that the IDS may be submitted, and all cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom. To that end, please find accompanying this document a Request for Continued Prosecution, the IDS and all fees required by 37 CFR § 1.17(e) and 37 CFR § 1.17(h).

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Based upon the foregoing, Applicants respectfully request the above-mentioned patent application be withdrawn from issue.

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents.

Signed:\_\_\_\_

Typed Name: Jennifer L. Cowlishaw

Date:\_

Respectfully Submitted,

Michael D. Carter

Reg. No. 56,661 Legal Department

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